

Notice of References Cited	Application/Control No. 10/757,698	Applicant(s)/Patent Under Reexamination LISOWSKI ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,874,923	04-2005	Albou et al.	362/512
	B	US-6,736,533	05-2004	Matsumoto et al.	362/539
	C	US-5,673,990	10-1997	Neumann et al.	362/513
	D	US-6,312,147	11-2001	Eichler, Heike	362/539
	E	US-6,494,603	12-2002	Takada, Kenichi	362/538
	F	US-2001/0019484	09-2001	Schauwecker et al.	362/539
	G	US-6,607,295	08-2003	Hayakawa, Michihiko	362/517
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	O					
	P					
	Q					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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